

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:)
Kenji ITOH et al.)
Serial No. 09/412,510)
Filed: October 5, 1999)
For: PROCESS FOR TREATING A SUBSTRATE WITH A)
PLASMA)

RECEIVED

Group Art Unit: 1762 JAN 14 2005

Examiner: Marianne Padgett

OFFICE OF PETITIONS

**PETITION FOR WITHDRAWAL FROM ISSUE TO PERMIT CONSIDERATION OF
INFORMATION DISCLOSURE STATEMENT UNDER
SECTION 1.97 IN A CONTINUING APPLICATION**

Office of the Petitions
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

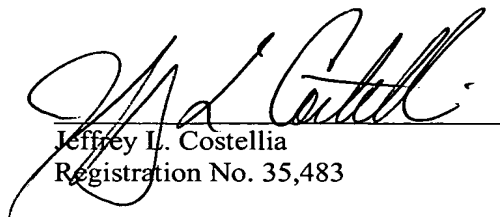
Applicants hereby petition for the withdrawal of this application from issue. The issue fee for this case was paid on December 29, 2004.

The reason for withdrawal from issue of this application is for consideration of information in a continuing application. The continuing application is filed as a Request for Continued Examination (RCE). The RCE, which is entitled to priority under 35 U.S.C. 120 from this application, is being filed on the same date as this petition and accompanies this petition.

The petition fee of \$130 under 37 C.F.R. 1.17(i) is enclosed. The Commissioner is authorized to charge the Petition Fee of \$130.00 or any deficiencies (except the issue fee) or credit any overpayment to Deposit Account No. 19-2380 (740756-2045). A duplicate copy of this sheet is attached.

01/18/2005 AKELLEY 00000001 192380 09412510
01 FC:1464 130.00 DA

Respectfully submitted,



Jeffrey L. Costellia
Registration No. 35,483

NIXON PEABODY LLP
401 9TH STREET, N.W., SUITE 900
Washington, D.C. 20004
(202) 585-8000